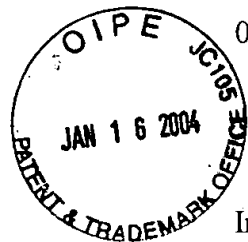


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03500.013974.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)

TADAHIRO OHMI ET AL.)

Application No.: 09/985,707)

Filed: November 6, 2001)

For: LASER GAS SUPPLY PATH)
 STRUCTURE IN AN EXPOSURE)
 APPARATUS)

Examiner: Davienne N. Monbleau

Group Art Unit: 2828

January 12, 2004

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

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AMENDMENT AND PETITION FOR EXTENSION OF TIME

Sir:

a) Introductory Comments

Applicants petition for a one month extension of time from September 12, 2003 to and including January 12, 2004 to extend the time for response to the outstanding Office Action dated September 12, 2003. A check in the amount of \$110.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension and credit any overpayment to Deposit Account No. 06-1205.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313 on
 January 12, 2004
 (Date of Deposit)

01/21/2004 CNGUYEN 00000017 09985707

01 FC:1251

110.00 OP

Peter Saxon (24947)

(Name of Attorney for Applicant)

Peter Saxon
 Signature

January 12, 2004
 Date of Signature